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SERIAL NUMBER 10/697,214	FILING DATE 10/29/2003 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. H1508
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APPLICANTS

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** CONTINUING DATA *****

This appln claims benefit of 60/501,445 09/09/2003

g/b

** FOREIGN APPLICATIONS *****

NONE g/b

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 01/30/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>William M. Bruneau</i> Examiner's Signature Initials	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 3
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ADDRESS

47332

THE CAVANAGH LAW FIRM

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TITLE

Semiconductor component and method for precluding stress-induced void formation in the semiconductor component

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